Notice of Allowability	Application No.	Applicant(s)
	10/635,571	OKINO ET AL.
	Examiner	Art Unit
	Yvette C. Thornton	1752
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication IGHTS. This application is subject to	orrespondence address plication. If not included
1. A This communication is responsive to preliminary amendme	ent filed on November 6, 2003.	
2. X The allowed claim(s) is/are 30-41.		
3. The drawings filed on <u>07 August 2003</u> are accepted by the	Examiner.	
 4. Acknowledgment is made of a claim for foreign priority unda	been received. been received in Application No. 09/cuments have been received in this not this communication to file a reply communication. Ited. Note the attached EXAMINER'S is reason(s) why the oath or declaration to be submitted. In the Submitted of the Submitted of the Submitted. Amendment / Comment or in the Offenders.	complying with the requirements S AMENDMENT or NOTICE OF ion is deficient. 48) attached
Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the 7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT Files.	e header according to 37 CFR 1.121(d) it of BIOLOGICAL MATERIAL mi	ust be submitted. Note the
Attachment(s)		
 I.	5. Notice of Informal Pat	·
	6. ☐ Interview Summary (F Paper No./Mail Date	
B. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date <u>08072003,09022003</u> , ווסר 2003, סו	3). 7. T Examiner's Amendme	ent/Comment
Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Statement	t of Reasons for Allowance
of Biological Material	9. Other	
		Yvette Clarke Thornton Patent Examiner Art Unit: 1752

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REASONS FOR ALLOWANCE

This is written in reference to application number 10/635571 filed on August 7, 2003 and published as US 2004/0043324 al on March 4, 2004, which is a continuation of US 6541597, which is a divisional of US 6303266.

Response to Amendment

- 1. The preliminary amendments filed on August 7, 2003 and November 6, 2003 have been entered and fully considered.
- 2. Claims 1-29 have been cancelled. Claims 30-41 are currently pending.

Information Disclosure Statement

3. The Information Disclosure Statements filed on August 7, 2003, September 2, 2003, November 7, 2003 and April 15, 2004 have been entered and fully considered.

Allowable Subject Matter

- 4. Claims 30-41 are allowed.
- 5. The following is an examiner's statement of reasons for allowance: review of the prior art failed to teach and/or suggest a composition and method of using as set forth in the present claims, which antedates the present application's effective filing date of the September 23, 1999.
- 6. The closest prior art reference to Funaki et al. (US 6692889 B1) teaches a photoresist composition comprising at least one monomer unit of formulae (I)-(IV) where formula (IV)

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has the structure , wherein R12-14 are each a hydrogen atom or a hydroxyl group. See examples 81-83. The said reference has a publication date of February 17, 2004 and an effective filing date of April 5, 2001. Therefore the said reference is not citable under as prior art under the stature of 35 USC 102(b), (e) or (a).

7. The prior art reference to Ushirogouchi et al. (US 6440636 B1) discloses a resin

composition comprising at least one monomeric unit of formula (I)

wherein

R2 and R3 is independently a hydrogen atom or a hydroxyl group. See example 10-11, 17-19 and 20-21. The said reference has a publication date of August 27, 2002 and filing date of November 2, 2000. Therefore, the reference is not citable as prior art under 35 USC 102(b), (e) or (a).

8. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

- 9. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Yvette C. Thornton whose telephone number is 571-272-1336. The examiner can normally be reached on Monday-Thursday from 8:00 am to 6:30 pm.
- 10. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark F. Huff, can be reached on 571-272-1385. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.
- 11. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

vette Clarke Thornton

Patent Examiner Art Unit 1752

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June 13, 2004